Atty. Dkt. No. AMAT/5908/CPI/ALUMINUM/PJS



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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in re Application of:

Wang, et al.

Serial No.: 10/046,954

Confirmation No.: 4418

Filed:

January 14, 2002

For:

Semiconductor Wafer

Preheating

MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Group Art Unit: 2125

Examiner:

Kidest Bahta

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SEP 0 3 2004

CERTIFICATE OF NOCKNOLOGY Center 2100

I hereby certify that this correspondence is being deposited on 8/25/07 with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

8/25/04 Date

Signature

RESPONSE TO OFFICE ACTION DATED MAY 26, 2004

In response to the Office Action dated May 26, 2004, having a shortened statutory period for response set to expire on August 26, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/5908/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. Remarks begin on page 12 of this paper.

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